

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/717,078	<b>Applicant(s)/Patent under Reexamination</b> KENNEDY ET AL.
<b>Examiner</b> Jacob Y. Choi	<b>Art Unit</b> 2875	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner